

Title (en)

DEVICE AND METHOD FOR STACKING OR TRANSPORTING A PLURALITY OF FLAT SUBSTRATES

Title (de)

VORRICHTUNG UND VERFAHREN ZUM STAPELN BZW. TRANSPORT EINER VIELZAHL VON FLACHEN SUBSTRATEN

Title (fr)

DISPOSITIF ET PROCÉDÉ D'EMPILEMENT OU DE TRANSPORT DE PLUSIEURS SUBSTRATS PLATS

Publication

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Application

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Abstract (en)

[origin: WO2010136568A1] The invention relates to a device for stacking a plurality of silicon wafers, comprising an upright machine carrier for accommodating a plurality of the silicon wafers, wherein the silicon wafers are provided in the machine carrier in a horizontal position. The device comprises three identical loading cassettes for introducing some silicon wafers therein. The machine carrier also comprises accommodating devices for the loading cassettes, wherein a loading cassette comprises a lower supporting surface on which the silicon wafers can be stacked and a rear side extending substantially perpendicularly thereto. The loading cassette is designed in such a way that the side opposite the rear side and the top side are freely accessible.

IPC 8 full level

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